

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
RD-27,376-4SERIAL NO.
09/578,095INFORMATION DISCLOSURE STATEMENT BY APPLICANT
LIST OF ITEMSApplicant
JAMES K. ARAGONES, ET ALFiling Date
5/25/00Group
2123

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KJW	AA 5,608,845	3/4/97	OHTSUKA, ET AL	702	189	JAN 14 2004
KJW	AB 6,381,556	4/30/02	KAZEMI, ET AL	702	189	
KJW	AC 6,532,427	3/11/03	JOSHI, ET AL	702	84	
	AD					
	AE					

Technology Center 2100

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	B1					
	B2					
	B3					

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

KJW	C1	YONG HWAN KIM, "A FORECASTING METHODOLOGY FOR MAINTENANCE COST OF LONG-LIFE EQUIPMENT", A DISSERTATION, TUSCALOOSA, AL, 1989, PG. 1 - 221.
KJW	C2	STEVE VESTAL, "ON THE ACCURACY OF PREDICTING RATE MONOTONIC SCHEDULING PERFORMANCE", 1990 ACM 0-897-409-0/90/1200, PP. 244-253.
KJW	C3	ROBB NEWMAN, "PERFORMANCE ANALYSIS CASE STUDY: APPLICATION OF EXPERIMENTAL DESIGN & STATISTICAL DATA ANALYSIS TECHNIQUES", 1991 ACM 089791-392-2/91/005/0214, PP. 214-215.

EXAMINER

DATE CONSIDERED

2/24/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
K/S	AA 5,455,777	10/3/95	FUJIYAMA, ET AL	702	34	
K/S	AB 6,067,486	5/23/00	ARAGONES, ET AL	701	29	
	AC					
	AD					
	AE					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
K/S	B1 WO 98/24042	6/4/98	PCT			
	B2 EP0867841 A2	9/30/98	EPO			
K/S	B3 JP2000097814	7/4/00	Patent Abstracts of Japan			

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

C1	
C2	
C3	

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